

2/11/05

Form PTO-1449 (SNL-Modified) (2-91)
List of Patents and Publications
for Applicant's
Information Disclosure Statement

Atty Docket No: SD-8287.1
Serial Number: 10/804,771

Applicant: MORALES

(use several sheets if necessary)

GROUP: FILING DATE: 03/19/04

REFERENCE DESIGNATION

Ex'r	U.S. Patent Documents			Sub		
Init	Document No.	Date	Name	Class	Class	Filing Date (when applicable)

IAA

Ex'r	Foreign Patent Documents			Sub	Translation?	
Init	Document No.	Date	Name	Class	Class	Yes No

IBA

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

W7 ICA Chou, S. Y., Maluf, N. I.; Peasea, R. F. W.; "High-resolution and high-fidelity x-ray mask structure employing embedded absorbers", *Journal of Vacuum Science and Technology, B* v.6 (6), pp. 2202 - 2206, Nov/Dec 1988

Examiner: *Michael H. [Signature]*

Date Considered: 7/29/05